

<b>Notice of References Cited</b>	Application/Control No. 10/630,818	Applicant(s)/Patent Under Reexamination FULLERTON ET AL.	
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*	B	US-5,465,185	11-1995	Heim et al.	360/324.11
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**NON-PATENT DOCUMENTS**

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	W	Abarra et al., "Longitudinal Magnetic Recording Media with Thermal Stabilization", Program of the 2000 IEEE International Magnetism Conference, 4/9/00-4/13/00, p. AA-06
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.